DOCKET NO: 245768US0TTC

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

;

MASAMI ENDA, ET AL.

: EXAMINER:

SERIAL NO: 10/717,628

:

FILED: NOVEMBER 21, 2003

: GROUP ART UNIT: 1746

FOR: SYSTEM AND METHOD FOR CHEMICAL DECONTAMINATION OF

RADIOACTIVE MATERIAL

SUPPLEMENTAL STATEMENT REQUIRED

UNDER SECTION 152 OF THE ATOMIC ENERGY ACT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Now come Masami Enda, Yumi Yaita, Mitsuyoshi Sato, Hitoshi Sakai, Takeshi Kanasaki and Ichiro Inami who depose and state that:

1. We are the named Applicants in the above-identified application, and that the full facts concerning the circumstances under which the present invention was made and the relation of such invention to the performance of any work under any contract, subcontract, or arrangement entered into with or for the benefit of the Atomic Energy Commission, the Energy Research and Development Administration or the Department of Energy are as follows:



2. The above invention was made, conceived and reduced to practice entirely on the time and efforts of the Applicants and at the sole expense and for the sole benefit of the Applicants' Assignee, Kabushiki Kaisha Toshiba, with offices at Tokyo, Japan, during our course of regular employment with said company at their facilities in Tokyo and Kanagawaken, Japan.

3. The invention or discovery was not made, or conceived in the course of or under any contract, subcontract, or arrangement entered into with or for the benefit of the United States Atomic Energy Commission, the Energy Research and Development Administration, or Department of Energy.

4. We declare under penalty of perjury under the laws of the United States of America that the foregoing is believed to be true and correct.

Masami Enda

Masami Enda Signature

May 19, 2004

Yumi Yaita

<u>May 19, 2004</u> Date

Mitsuyoshi Sato

Hitoshi Sakai

Takeshi Kanasaki

Takeshi Kanosaki Signature

May, 20, 2004 Date

Ichiro Inami

Signature

May . 20, 2004

Date